



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tetsuo YAMADA, et al.
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN
FILM PIEZOELECTRIC DEVICE, AND
MANUFACTURING METHOD THEREOF (As Amended)
Filing Date : December 17, 2004
Examiner : Not Yet Assigned
Group Art Unit : 2834
Confirmation No. : 5674

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I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
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Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April
24, 2006.

Ronald R. Santucci, Reg. No. 28,988
(Name of Applicant, Assignee or Registered Representative)

Signature

April 24, 2006

Date of Signature

FOURTH PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the above-referenced patent application,

Applicants respectfully request that the application be further amended as follows.